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IBM Docket No. BUR920000141US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Nicole S. Carpenter et al.**

Serial No.:

09/892,954

Date:

February 25, 2004

Filed:

June 27, 2001

Group Art Unit:

1746

Title:

**CLEANING OF SEMICONDUCTOR
WAFERS BY CONTAMINATE
ENCAPSULATION**

Examiner:

Gentle E. Winter

DeLIO & PETERSON, LLC

121 Whitney Avenue

New Haven, CT 06510-1241

LETTER TO OFFICIAL DRAFTSMAN

Mail Stop ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450


Dear Sir:

Applicants are herewith submitting 3 sheets of Formal Drawings for the approval of the Draftsman.

Please charge the Assignee IBM Corporation Deposit Account No. **09-0456** for any fee related to the acceptance of the attached Formal Drawings. A duplicate copy of this letter is enclosed for that purpose.

Respectfully submitted,

BY:


Attorney: **John J. Tomaszewski**
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